



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki, et al. Art Unit : 1765
Serial No. : 09/966,689 Examiner : Kin-Chan Chen
Filed : September 27, 2001
Title : DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF
FORMING A WIRING

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MARCH 25, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of the claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.